

TRANSMITTAL
(Only for new nonprovisional applications under 37 CFR 1.53(b))


Title	METHOD OF FORMING A POLYCRYSTALLINE SILICON LAYER
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US. PTO.
09/17/88
12/28/00

³See MPEP chapter 600 concerning utility patent application contents.

ADDRESS TO:

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Name:	Song K. Jung	Registration No.:	35,210
Signature:		Date:	December 28, 2000
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Docket No. 8733.378.00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Myoung-Su YANG

SERIAL NO: To Be Assigned

FILING DATE: December 28, 2000

FOR: METHOD OF FORMING A POLYCRYSTALLINE SILICON LAYER

FEE TRANSMITTAL

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

FOR	NUMBER FILED	NUMBER EXTRA	RATE	CALCULATIONS
TOTAL CLAIMS	6 - 20 =	0	× \$18 =	\$0.00
INDEPENDENT CLAIMS	1 - 3 =	0	× \$80 =	\$0.00
<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS (If applicable)			+ \$270 =	\$0.00
<input checked="" type="checkbox"/> LATE FILING OF DECLARATION			+ \$130 =	\$130.00
BASIC FEE				\$710.00
TOTAL OF ABOVE CALCULATIONS				\$840.00
<input type="checkbox"/> REDUCTION BY 50% FOR FILING BY SMALL ENTITY				\$0.00
<input type="checkbox"/> FILING IN NON-ENGLISH LANGUAGE			+ \$130 =	\$0.00
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TOTAL				\$840.00

Please charge Deposit Account No. 50-0911 in the amount of

A duplicate copy of this sheet is enclosed.

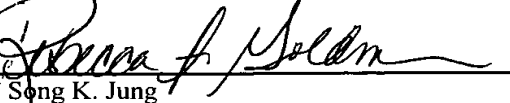
A check in the amount of \$710.00 to cover the filing fee is enclosed.

The Commissioner is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to Deposit Account No. 50-0911.

A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

LONG ALDRIDGE & NORMAN LLP


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: **Myoung-Su YANG**

GAU: TBA

SERIAL NO: **To Be Assigned**

EXAMINER: TBA

FILED: **December 28, 2000**

FOR: **METHOD OF FORMING A POLYCRYSTALLINE SILICON LAYER**

REQUEST FOR PRIORITY

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

- ☐ Full benefit of the filing date of U.S. Application Serial Number [US App No], filed [US App Dt], is claimed pursuant to the provisions of **35 U.S.C. §120**.
- ☐ Full benefit of the filing date of U.S. Provisional Application Serial Number , filed , is claimed pursuant to the provisions of **35 U.S.C. §119(e)**.
- ☒ Applicants claim any right to priority from any earlier filed applications to which they may be entitled pursuant to the provisions of **35 U.S.C. §119**, as noted below.

In the matter of the above-identified application for patent, notice is hereby given that the applicants claim as priority:

COUNTRY
KOREA

APPLICATION NUMBER
1999-67846

MONTH/DAY/YEAR
December 31, 1999

Certified copies of the corresponding Convention Application(s)


- ☐ are submitted herewith
- ☒ will be submitted prior to payment of the Final Fee
- ☐ were filed in prior application Serial No. filed
- ☐ were submitted to the International Bureau in PCT Application Number .
Receipt of the certified copies by the International Bureau in a timely manner under PCT Rule 17.1(a) has been acknowledged as evidenced by the attached PCT/IB/304.
- ☐ (A) Application Serial No.(s) were filed in prior application Serial No. filed ; and
(B) Application Serial No.(s)
 - ☐ are submitted herewith
 - ☐ will be submitted prior to payment of the Final Fee

Respectfully Submitted,

Date: December 28, 2000

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Song K. Jung
Registration No. 35,210

Rebecca A. Goldman
Registration No. 41,786

Docket No. 8733.378.00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Myoung-Su YANG

FILING DATE: December 28, 2000

FOR: METHOD OF FORMING A POLYCRYSTALLINE SILICON LAYER

LIST OF INVENTORS' NAMES AND ADDRESSES

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

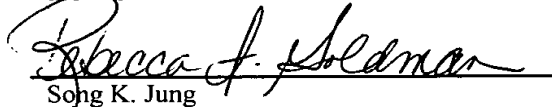
Listed below are the names and addresses of the inventors for the above-identified patent application.

1. Myoung-Su YANG
1401/605 Machwa Apt., 1055 Sanbon1-dong
Kunpo-shi, Kyonggi-do, 435-041
REPUBLIC OF KOREA

A declaration containing all the necessary information will be submitted at a later date.

Respectfully Submitted,

LONG ALDRIDGE & NORMAN LLP



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Rebecca A. Goldman
Registration No. 41,786

Date: December 28, 2000

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